Docket No.

245161US3CIP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tsutomu OKABE, et al.

10/706,914 SERIAL NO:

GAU:

1763

RCE FILED: HEREWITH (Application filed: November 14, 2003) EXAMINER: MOORE, K.

FOR:

WAFER PROCESSING APPARATUS HAVING DUST PROOF FUNCTION

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a one month extension of time be granted to December 22, 2005 for	
	filing a response to the Official Action dated: August 22, 2005.
	responding to the requirements in the Notice of Allowability dated:
	filing the Formal Drawings. The Issue Fee due has been timely filed.
	responding to the Notice to File Missing Parts of Application dated:
	filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
	filing a Request for Continued Examination (RCE).
	Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$120.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELI MAIER & NEUSTADT, P.C.

Gregory J(Maier

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Customer Number

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Raymond F. Cardillo, Jr.

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